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September 2, 2003

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MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Application of Kunio KAWAKAMI, Osamu KOSHIISHI, Kazuo TANAKA

Osamu HANAMURA

SHIELDING DEVICE FOR ANTENNA BOARD, AND LIQUID EJECTION

APPARATUS INCORPORATING THE SAME Assignee: SEIKO EPSON CORPORATION

Our Ref. Q77254

Dear Sir:

Attached hereto is the application identified above comprising 31 sheets of the specification (Japanese Language), including the claims and abstract and 29 sheets of drawings. The requisite U.S. Government Filing Fee, verified English Translation, executed Declaration and Power of Attorney and Assignment will be submitted at a later date. Also enclosed is an Information Disclosure Statement and PTO/SB/08 A & B (modified).

The Government filing fee is calculated as follows:

Total claims	10	-	20	=_	X	\$18.00	=	\$.00
Independent claims	1	_	3	=_	X	\$84.00	=	\$.00
Base Fee								\$750.00

TOTAL FEE \$750.00

Priority is claimed from:

 Country
 Application No
 Filing Date

 Japan
 2002-252599
 August 30, 2002

 Japan
 2003-306009
 August 29, 2003

The priority documents will be filed at a later date.

Respectfully submitted, SUGHRUE MION, PLLC Attorneys for Applicant

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